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Bib Data Sheet

CONFIRMATION NO. 3652

SERIAL NUMBER 09/977,238	FILING DATE 10/16/2001 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. SEC.895
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APPLICANTS
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 Sang-Kil Lee, Suwon-si, KOREA, REPUBLIC OF;

**** CONTINUING DATA *******

**** FOREIGN APPLICATIONS *******
 REPUBLIC OF KOREA 2000-61717 10/19/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
**** 11/15/2001**

Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 21	TOTAL CLAIMS 31	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

ADDRESS
 JONES VOLENTINE, P.L.L.C.
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 Reston , VA 20191

TITLE
 Method and apparatus for numerically analyzing grain growth on semiconductor wafer using SEM image

FILING FEE RECEIVED 1022	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees (Filing)
		<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
		<input type="checkbox"/> 1.18 Fees (Issue)
		<input type="checkbox"/> Other _____
		<input type="checkbox"/> Credit